



10 / 643, 917

IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Tsuneo KAGOTANI et al.

Patent No.: 7,192,676

Filed: August 20, 2003

Docket No.: 116900

For: MAGNETO-RESISTANCE EFFECT ELEMENT BAR EXPOSURE METHOD

NOTICE OF CHANGE OF ADDRESS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please address all future communications in connection with the above-identified application to:

**OLIFF & BERRIDGE, PLC
CUSTOMER NUMBER 25944**

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Linda M. Saltiel
Registration No. 51,122

JAO:LMS/tls

Date: April 25, 2007

**OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400**

<p>DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
